

**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)

Docket Number (Optional)

NEC 01FN073

Application Number

10/077,639

Applicant(s)

SHIRAKAWA et al.

Filing Date

February 15, 2002

Group Art Unit

2651 2656

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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**U.S. PATENT APPLICATION PUBLICATIONS**

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**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
ur		2000-155979	6.6.00	JAPAN (w/abstract)	G11B	7/135		
ur		2000-057616	2.25.00	JAPAN (w/abstract)	G11B	7/135		
ur		2000-171346	6.23.00	JAPAN (w/abstract)	G01M	11/00		
*		2001-507463	5.6.01	JAPAN	G01M	11/02		

**OTHER DOCUMENTS**

(Including Author, Title, Date, Pertinent Pages, Etc.)

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X		

EXAMINER

CRP

DATE CONSIDERED

2/26/06

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

\* not considered